

**PATENT NUMBER**

TO: OI.P.E. PATEL

SCANNED 3:00 PM

**Figure 6**

APPLICANT	Mitsutoshi Miyasaka
TITLE	Fabrication method for a thin film semiconductor device, the thin film semiconductor device itself, liquid crystal display, and electronic device

PTC-2040  
12/99

<b>ISSUING CLASSIFICATION</b>								
<b>ORIGINAL</b>		<b>CROSS REFERENCE(S)</b>						
<b>CLASS</b>	<b>SUBCLASS</b>	<b>CLASS</b>	<b>SUBCLASS (ONE SUBCLASS PER BLOCK)</b>					
<b>INTERNATIONAL CLASSIFICATION:</b>								

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